

**[SIMULATION OF PULL-IN
EFFECT IN MEMS
CAPACITOR USING GUI IN
MATLAB]**

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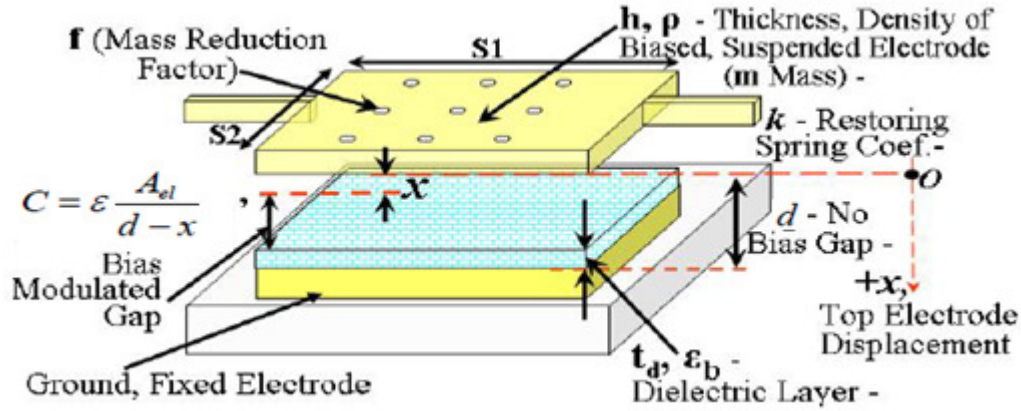
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SIMULATION OF PULL-IN EFFECT IN MEMS CAPACITOR USING GUI IN MATLAB

pull-in effect in electrostatic MEMS devices:

Figure shows the schematic of an electrostatic actuator that could be used for example as a tunable RF capacitor. When voltage is applied over the capacitance, electrostatic force will work to reduce the plate separation $d - x$. At small voltages, the electrostatic voltage is countered by the spring force $F_k = kx$ but as voltage is increased the plates will eventually snap together. Estimating this pull-in voltage U_P and the plate travel distance x before pull-in effect is required for the successful design of electrostatic actuators, switches, varactors, and sensors.



The plate is attached to a spring k . The capacitor capacitance C depends on the plate area A_{el} and gap $d - x$.

$$E = -\frac{1}{2} \frac{\epsilon A_{el}}{d - x} U^2 + \frac{1}{2} kx^2, \quad (1)$$

where the first term is the electrostatic potential of the deformable capacitor and of the voltage source and the second term is due to the mechanical energy stored in the spring. The force acting on the movable plate is obtained by deriving Equation (1):

$$F = -\frac{\partial E}{\partial x} = \frac{1}{2} \frac{\epsilon A_{el}}{(d - x)^2} U^2 - kx. \quad (2)$$

At equilibrium, the electrostatic force and spring force cancels ($F = 0$) and Equation (2) gives:

$$kx = \frac{1}{2} \frac{\epsilon A_{el}}{(d - x)^2} U^2. \quad (3)$$

Equation (3) can be solved for the equilibrium plate position x as a function of applied voltage U as shown

in Figure 2(a). Above the pull-in voltage V_P , Equation (3) has no solutions. The solution above the pull-in

displacement (green line) are shown to be unstable in the following. A simple expression for the pull-in point is obtained by deriving Equation (2) to obtain the stiffness of the system:

$$\frac{\partial F}{\partial x} = \frac{\epsilon A_{el}}{(d - x)^3} U^2 - k. \quad (4)$$

Substituting Equation (3) gives the stiffness around the equilibrium point:

$$\frac{\partial F}{\partial x} = \frac{2kx}{(d-x)^3} - k. \quad (5)$$

Here near the $2/3^{\text{rd}}$ of total gap between the plates the response of the mems capacitor gets unstable. Beyond this point the stiffness becomes positive and the system is unstable: a small positive movement dx result in positive force that increases x . the pull-in voltage at which the system becomes unstable

The expression for pull –in voltage and gap between plates is given by:

$$U_p = \sqrt{\frac{8}{27} \frac{kd^3}{\epsilon A_{el}}}.$$

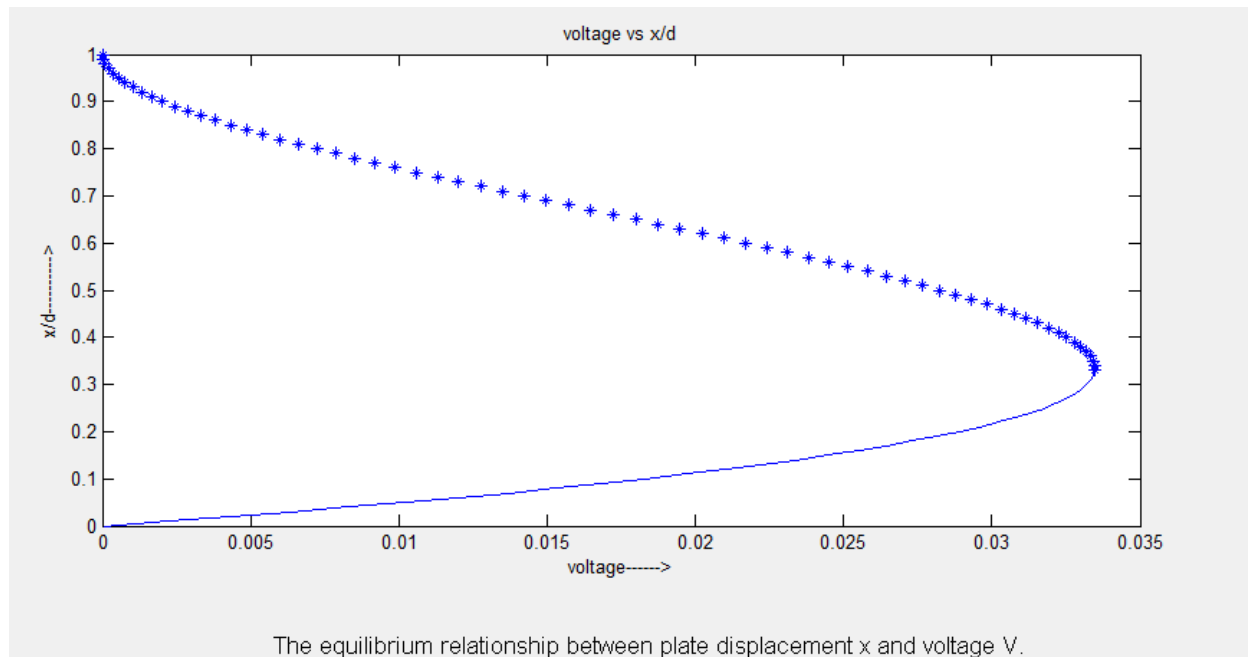
>>Where U_p is voltage across the plates of the Mems capacitor.

>> K is the spring stiffness constant.

>> D is the distance b/w plates.

>> ϵ is the permittivity of the medium.

>> A is the area overlapped.



Matlab code to generate the plot and simulation of MEMS device pull-in effect.

```
k=1e-8;
e = 8.854 * 10 ^ -12;
d = 1; % in mm
% in mm
% a = input('Enter the value of a: ');
a=10000;
x = 1: -0.01 : .33; % in mm
V = (2/(e*a)) * k * x .* ((d - x).^2);
plot(V,x/d, '*')
hold on;
x = .33: -0.01 : 0;
V = (2/(e*a)) * k * x .* ((d - x).^2);
plot(V,x/d)
ylabel('x/d----->');
xlabel('voltage----->');
title('voltage vs x/d');
```

GRAPHICAL USER INTERFACE:

